## Reexamination 10/658,687 YOSHIMURA, HIROYUKI Notice of References Cited Examiner Art Unit

Application/Control No.

Maureen G. Arancibia 1763

Page 1 of 1

Applicant(s)/Patent Under

## **U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	Α	US-5,580,639	12-1996	Togawa et al.	428/156
	В	US-6,613,459	09-2003	Saito et al.	428/692
	С	US-5,998,261	12-1999	Hofmann et al.	438/257
	D	US-5,770,465	06-1998	MacDonald et al.	216/2
	Е	US-			
	F	US-			
	G	US-			
	Н	US-			
	ı	US-			
	J	US-			
	γK	US-			
	L	US-			
	М	US-			

## FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	Z					
	0					
	Р					
	Q					
	R					
	s					
	Т					

## **NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	"Etch Rates for Micromachining Processing" by Williams et al. Journal of Microelectromechanical Systems, Vol. 5, No. 4, December, 1996, pages 256-269.
	V	"Ferrite devices" by Chin. In AccessScience@McGraw-Hill, http://www.accessscience.com, DOI 10.1036/1097-8542.254100, last modified: January 28, 2002. Downloaded on 09/27/2004.
	w	JPO Machine English Translation of Japanese Publication 11-339242. Obtained from http://www19.ipdl.jpo.go.jp/ on 09/28/2004.
	х	

A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).) Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.